

Applicant:

David Fairbourn

Serial No:

10/613,620

Filing Date:

July 3, 2003

Art Unit:

1763

Examiner:

Jeffrie Robert Lund

Title:

SIMPLE CHEMICAL VAPOR DEPOSITION SYSTEM AND

METHODS FOR DEPOSITING MULTIPLE-METAL ALUMINIDE

COATINGS

Confirmation No.:

4378

Attorney Docket:

MTCL-09

Cincinnati, Ohio 45202

August 5, 2004

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Prior to examination, please preliminarily amend this application as

follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 16 of this paper.